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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Tetsuya IKUTA et al.**

Group Art Unit: **2814**

Application Number: **10/809,809**

Examiner: **Thao X. Le**

Filed: **March 26, 2004**

Confirmation Number: **7816**

For: **SEMICONDUCTOR MANUFACTURING METHOD FOR  
IMPROVING CARRIER MOBILITY AND REDUCING LEAK  
CURRENT (AS AMENDED)**

Attorney Docket Number: **042278**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. §1.111**

**Mail Stop: Amendment**

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

November 3, 2006

Sir:

This paper is filed in response to the Office Action dated August 9, 2006.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.